



00862.022173

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,906

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
METHOD OF MANUFACTURING THE
SAME, CHARGED-PARTICLE BEAM
EXPOSURE APPARATUS, AND DEVICE
MANUFACTURING METHOD

Examiner: K.T. Nguyen
Group Art Unit: 2881
Confirmation No.: 5368
January 30, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIXTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on October 23, 2001, the Supplemental Information Disclosure Statement filed on January 29, 2003, the Second Supplemental Information Disclosure Statement filed on June 4, 2003, the Third Supplemental Information Disclosure Statement filed on October 14, 2003, the Fourth Information Disclosure Statement filed on November 6, 2003, and the Fifth Information Disclosure Statement filed on December 12, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

The Examiner's attention is also directed to copending U.S. patent application number 10/454,576, filed June 5, 2003. A copy of this application is also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/eab



Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date 12/12/2003

Mo. Day Yr.

Atty. Docket 0022-000173

Application 09/819,906



Sir:

Kindly acknowledge receipt of the accompanying:

Response to Official Action. _____
 Check for \$ _____ (claims fee)
 Petition under 37 CFR 1.136 and Check for \$ _____
 Notice of Appeal and Check for \$ _____
 Information Disclosure Statement, PTO-1449 and Seven (7) documents
 Claim for priority and certified copies of _____ priority applications
 Issue fee transmittal and Check for \$ _____
 Other (specify) _____

by placing your receiving date stamp hereon and returning to deliverer.

Atty. SEAN GOB

Due Date 12/12/2003

Mo. Day Yr.

FS-508



00862.022173

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yasuhiro SHIMADA et al.) Examiner: K.T. Nguyen
Application No.: 09/819,906) Group Art Unit: 2881
Filed: March 29, 2001) Confirmation No.: 5368
For: ELECTRON OPTICAL SYSTEM ARRAY,) December 12, 2003
METHOD OF MANUFACTURING THE)
SAME, CHARGED-PARTICLE BEAM)
EXPOSURE APPARATUS, AND DEVICE)
MANUFACTURING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on October 23, 2001, the Supplemental Information Disclosure Statement filed on January 29, 2003, the Second Supplemental Information Disclosure Statement filed on June 4, 2003, the Third Supplemental Information Disclosure Statement filed on October 14, 2003, and the Fourth Information Disclosure Statement filed on November 6, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

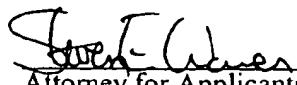
U.S. Patent Nos. 4,419,182, 4,569,033 and 5,260,579 were cited in a Notice of Art Cited by the Examiner (PTO-892 Form) attached to a Notice Allowance issued November 10, 2003, in copending U.S. patent application number 09/819,737.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/eab



Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date 11/6/2003
Mo. Day Yr.
Atty. Docket # 0082-022173
Application # 07/819,906

Sir:

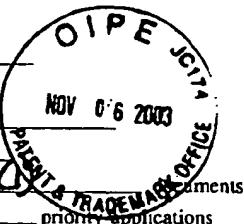
Kindly acknowledge receipt of the accompanying:

Response to Official Action. _____
 Check for \$ _____ (claims fee)
 Petition under 37 CFR 1.136 and Check for \$ _____
 Notice of Appeal and Check for \$ _____
 Information Disclosure Statement, PTO-1449 and one (1) copy of the ~~Information Disclosure Statement~~ priority applications
 Claim for priority and certified copies of _____ priority applications
 Issue fee transmittal and Check for \$ _____
 Other (specify) _____

by placing your receiving date stamp hereon and returning to deliverer.

Atty. SEAN EDB

Due Date 11/6/2003
Mo. Day Yr.





00862.022173

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yasuhiro SHIMADA et al.

Application No.: 09/819,906

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
METHOD OF MANUFACTURING THE
SAME, CHARGED-PARTICLE BEAM
EXPOSURE APPARATUS, AND DEVICE
MANUFACTURING METHOD

)
:
Examiner: K.T. Nguyen
)
:
Group Art Unit: 2881
)
:
Confirmation No.: 5368
)
:
November 6, 2003
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FOURTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on October 23, 2001, the Supplemental Information Disclosure Statement filed on January 29, 2003, the Second Supplemental Information Disclosure Statement filed on June 4, 2003, and the Third Supplemental Information Disclosure Statement filed on October 14, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed PTO-1449 form. Copies of the listed document and its English translation are also enclosed.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW/eab